

Docket No.: K-0319



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of  
In Haeng Cho

Confirmation No.: 1269

Group Art Unit: 1746

Serial No.: 09/944,378

Examiner: Joseph L. Perrin

Filed: September 4, 2001

Customer No.: 34610

For: WASHING MACHINE AND SYSTEM DATA CHANGING MEHOD OF THE  
SAME

**COMMENTS IN REPLY TO EXAMINER'S  
STATEMENT OF REASONS FOR ALLOWANCE**

U.S. Patent and Trademark Office  
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Sir:

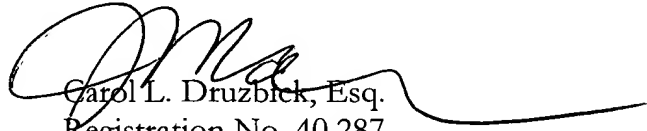
In response to the Notice of Allowability dated August 25, 2005, Applicant respectfully submits the following Comments on Statement of Reasons for Allowance.

The Examiner provided various reasons for allowance of the above-identified application in the Notice of Allowability. Applicants respectfully note that the Examiner has misquoted the language recited in the independent claims.

Accordingly, Applicants respectfully submit that the scope of the allowed claims should not be limited by the comments for reasons of allowance in the Notice of Allowability.

Should there be any questions concerning this communication, please telephone  
the undersigned at the telephone number set forth below.

Respectfully submitted,  
FLESHNER & KIM, LLP



Carol L. Druzbeck, Esq.  
Registration No. 40,287  
Joanna K. Mason  
Registration No. 56,408

P.O. Box 221200  
Chantilly, Virginia 20153-1200  
703 766-3701 DYK/CLD:JKM/krf  
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